

IN THE UNITED STATES PATENT AND TRADEMARK OFFICEApplicant: **TSAI, John C.**For (title): **SYSTEM FOR ROTATION MEASUREMENT WITH LASER
5 INTERFEROMETRY**Filing Date: **20/08/2004**Serial No: **10/711,090**Examiner: **LYONS, MICHAEL A.**Art Unit: **2877**

10 Mail Stop Non-Fee Amendment
Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313

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RESPONSE TO OFFICE ACTION AND AMENDMENT

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Sir:

In response to the Office Action dated 11/06/2006, Applicant submits the following remarks and amendment, currently due on a statutory period for response now extending through 02/06/2007.